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## \*BIBDATASHEET\*

**CONFIRMATION NO. 7420** 

Bib Data Sheet	***********	ph								
	SERIAL NUMBER 10/706,944		(	LASS GROUP ART 216 1746		UNIT	ATTORNEY DOCKET NO. 101136-00103			
APPLICANTS										
Takaei Sasaki, Saitama-ken, JAPAN;										
Noriyuki Harashima, Saitama-ken, JAPAN; Satoshi Aoyama, Hyogo-ken, JAPAN;Shouichi Sakamoto, Hyogo-ken, JAPAN;										
** CONTINUING DATA **********************************										
** FOREIGN APPLICATIONS ************************************										
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/10/2004										
Foreign Priority claim 35 USC 119 (a-d) cor met		yes □ no □ Met after.	Allowance	STATE OR	SI	HEETS	TOTA	٩L	INDEPENDENT	
Verified and Acknowledged Ex		niner's Signature In	nitials	COUNTRY JAPAN	DR	AWING 7	CLAIN 2	иs	CLAIMS 2	
ADDRESS ARENT FOX KINTNER PLOTKIN & KAHN, PLLC SUITE 400 1050 CONNECTICUT AVENUE, N.W. WASHINGTON, DC 20036-5339										
TITLE  Method and apparatus for dry-etching half-tone phase-shift films, half-tone phase-shift photomasks and method for the preparation thereof, and semiconductor circuits and method for the fabrication thereof										
						☐ All Fees				
FILING FEE	FEES:	Authority has been give	ner		☐ 1.16 Fees ( Filing ) ☐ 1.17 Fees ( Processing Ext. of					
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770							☐ 1.18 Fees ( Issue ) ☐ Other			
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